1. Record Nr. UNINA9910824274703321 Autore Joseph Charles Lynn **Titolo** Modern devices: the simple physics of sophisticated technology / / by Charles L. Joseph and Santiago Bernal Pubbl/distr/stampa Hoboken, New Jersey:,: Wiley,, 2016 ©2016 **ISBN** 1-119-01183-3 1-119-01182-5 Descrizione fisica 1 online resource (688 p.) 670 Disciplina Soggetti Manufactures - Technological innovations Electronic apparatus and appliances - Technological innovations Industrial equipment - Technological innovations Optical instruments - Technological innovations Technology **Physics** Lingua di pubblicazione Inglese **Formato** Materiale a stampa Livello bibliografico Monografia Note generali Description based upon print version of record. Includes bibliographical references and index. Nota di bibliografia Nota di contenuto TITLE PAGE; TABLE OF CONTENTS; PREFACE; ABOUT THE COMPANION WEBSITE; 1 PRINCIPLES OF PHYSICS AND THE RELEVANCE TO MODERN TECHNOLOGIES; 1.1 CM, EM, AND QM: THE BACKBONE OF PHYSICS; 1.2 PHOTONICS AND ELECTRONICS; 2 EVERYDAY HOME APPLIANCES; 2.1 THE AIR CONDITIONER; 2.2 MICROWAVE OVENS; 2.3 SMOKE DETECTORS; 2.4 COMPACT DISCS, DIGITAL VERSATILE DISCS, AND BLU-RAY DISCS; 2.5 PHOTOCOPIERS AND FAX MACHINES; 3 DEVICES

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